References cited herein:

- U.S. Patent No. 7,604,716 ("'716 Patent")
- D.V. Mozgrin, *et al*, <u>High-Current Low-Pressure Quasi-Stationary Discharge in a Magnetic Field: Experimental Research</u>, Plasma Physics Reports, Vol. 21, No. 5, 1995 ("Mozgrin")
- A. A. Kudryavtsev, *et al*, <u>Ionization relaxation in a plasma produced by a pulsed inert-gas discharge</u>, Sov. Phys. Tech. Phys. 28(1), January 1983 ("Kudryavtsev")
- U.S. Pat. No. 6,190,512 ("Lantsman")
- Milton Ohring, The Material Science of Thin Films, Academic Press, 1992 ("Ohring")
- Donald L. Smith, Thin-Film Deposition: Principles & Practice, McGraw Hill, 1995 ("Smith")

Claims 19 and 20	Mozgrin in view of Kudryavtsev and Lantsman
14. A method for generating a strongly-ionized plasma, the method comprising:	The combination of Mozgrin with Kudryavtsev discloses a method for generating a strongly-ionized plasma.
	'716 Patent at claim 24 ("wherein the peak plasma density of the strongly-ionized plasma is greater than about 10 ¹² cm ⁻³ ")
	Mozgrin at Fig 1
	Mozgrin at 400, right col, ¶ 4 ("To study the high-current forms of the discharge, we used two types of devices: a planar magnetron and a ystem with specifically shaped hollow electrodes.")
	Mozgrin at 401, right col, $\P2$ ("For pre-ionization the initial plasma density in the $10^9 - 10^{11}$ cm ⁻³ range.")
	Mozgrin at 409, left col, ¶ 4 ("The implementation of the high-current magnetron discharge (regime 2) in sputtering plasma density (exceeding $2x10^{13}$ cm ⁻³).")
	Mozgrin at 409, left col, ¶5 ("The high-current diffuse discharge (regime 3) is useful for producing large-volume uniform dense plasmas $n_i \approx 1.5 \times 10^{15} \text{cm}^{-3}$ ").
a. ionizing a feed gas	The combination of Mozgrin with Kudryavtsev discloses ionizing a
in a chamber to form	feed gas in a chamber to form a weakly-ionized plasma that
a weakly-ionized	substantially eliminates the probability of developing an electrical



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plasma that	breakdown condition in the chamber.
substantially eliminates the probability of developing an electrical breakdown condition in the chamber; and	'716 Patent at 5:14-15 ("The weakly-ionized plasma 232 is also referred to as a pre-ionized plasma.")
	'716 Patent at claim 23 ("wherein the peak plasma density of the weakly-ionized plasma is less than about 10 ¹² cm ⁻³ ")
	Mozgrin at Figs. 1, 2, 3, 6, 7
	Mozgrin at 401, left col, ¶ 1 ("The [plasma] discharge had an annular shape and was adjacent to the cathode.")
	Mozgrin at 401, left col, ¶ 4 ("[A]pplying a square voltage pulse to the discharge gap which was filled up with either neutral or pre-ionized gas.")
	Mozgrin at 402, right col, ¶2 ("Figure 3 shows typical voltage and current oscillograms Part I in the voltage oscillogram represents the voltage of the stationary discharge (pre-ionization stage).")
	Mozgrin at 401, right col, $\P2$ ("[f]or pre-ionization, we used a stationary magnetron discharge; provided the initial plasma density in the $10^9 - 10^{11}$ cm ⁻³ range.")
	Mozgrin at 400, right col, \P 3 ("We investigated the discharge regimes in various gas mixtures at $10^{-3} - 10$ torr")
	Mozgrin at 402, ¶ spanning left and right cols ("We studied the high-current discharge in wide ranges of discharge currentand operating pressureusing various gases (Ar, N ₂ , SF ₆ , and H ₂) or their mixtures of various composition")
b. supplying an electrical pulse across the weakly-ionized plasma that excites atoms in the weakly-ionized plasma,	The combination of Mozgrin with Kudryavtsev discloses supplying an electrical pulse across the weakly-ionized plasma that excites atoms in the weakly-ionized plasma, thereby generating a strongly-ionized plasma without developing an electrical breakdown condition in the chamber.
thereby generating a strongly-ionized plasma without	'716 Patent at claim 23 ("wherein the peak plasma density of the weakly-ionized plasma is less than about 10 ¹² cm ⁻³ ")
developing an electrical breakdown	'716 Patent at claim 24 ("wherein the peak plasma density of the strongly-ionized plasma is greater than about 10 ¹² cm ⁻³ ")



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condition in the chamber.	Mozgrin at Fig. 1
	(a) Z Z B B F T T T T T T T T T T T T T T T T T
	Fig. 1. Discharge device configurations: (a) planar magnetron; (b) shaped-electrode configuration. (1) Cathode; (2) anode; (3) magnetic system.
	Mozgrin at Fig. 2
	High-voltage supply unit C C C C C C C C C C C C C
	Fig. 2. Discharge supply unit.
	Mozgrin at Fig. 3

Claims 19 and 20	Mozgrin in view of Kudryavtsev and Lantsman
	(a) 1 2a 2b 3
	(b) (b)
	1 2a 2b 3 Fig. 3. Oscillograms of (a) current and (b) voltage of the quasi-stationary discharge (50 μs per div., 180 A per div., 180 V per div.).
	Mozgrin at 402, right col, ¶ 2 ("Part 1 in the voltage oscillogram represents the voltage of the stationary discharge (pre-ionization stage).")
	Mozgrin at 401, right col, $\P2$ ("For pre-ionization the initial plasma density in the $10^9 - 10^{11}$ cm ⁻³ range.")
	Mozgrin at 401, right col, ¶ 1 ("Thus, the supply unit was made providing square voltage and current pulses with [rise] times (leading edge) of $5-60~\mu s$ ").
	Mozgrin 403, right col, ¶4 ("Regime 2 was characterized by intense cathode sputtering") (emphasis added).
	Mozgrin at 409, left col, ¶ 4 ("The implementation of the high-current magnetron discharge (regime 2) in sputtering plasma density (exceeding $2x10^{13}$ cm ⁻³).").
	Mozgrin at 409, left col, ¶5 ("The high-current diffuse discharge (regime 3) is useful for producing large-volume uniform dense plasmas $n_i \cong 1.5 \times 10^{15} \text{cm}^{-3}$ ")
	Mozgrin at 400, left col, ¶ 3 ("Some experiments on magnetron systems of various geometry showed that discharge regimes which do not transit to arcs can be obtained even at high currents.")
	Mozgrin at 400, right col, ¶ 1 ("A further increase in the discharge



Claims 19 and 20	Mozgrin in view of Kudryavtsev and Lantsman
	currents caused the discharges to transit to the arc regimes").
	Mozgrin at 404, left col, ¶ 3 ("The parameters of the shaped-electrode dischargetransit to arc regime 4, could be well determined The point of the planar-magnetron discharge transit to the arc regime was determined by discharge voltage and structure changes").
	Mozgrin at 404, left col, \P 4 ("If the current was raised above 1.8 kA or the pulse duration was increase to $2-10$ ms, an instability development and discharge contraction was observed.").
	Mozgrin at Fig. 4
	U, V 500 400 300 - 1
	200 -
	100 - 3
	0.1 1 10 100 1000 <i>I</i> , A
	Fig. 4. Current-voltage characteristic of the quasi-stationary discharge with shaped electrodes in argon, $p = 0.1$ torr; $B = 0.4$ kG.
	Mozgrin at Fig. 7
	500 - 1000 2
	70 - 170
	15 - 45
	0 15 - 225 1000 - 1800 <i>I</i> , A
	Fig. 7. Generalized ampere-voltaic characteristic CVC of quasi-stationary discharge.
	Mozgrin at 401, ¶ spanning left and right columns ("Designing the [pulsed supply] unit, we took into account the dependences which had been obtained in [Kudryavtsev] of ionization relaxation on pre-



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